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Attorney's Docket No.: 10417-118001 / F51-142893M/SW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yoshinori Hino et al.

Art Unit : 2826

Serial No. : 10/076,154

Examiner : Tan N. Tran

Filed : February 14, 2002

Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Copies of the references listed on the attached form PTO-1449 are enclosed.

English-language abstracts for both references are also enclosed. A copy of an Office action from the Korean Patent Office, as well as an English-language translation, also is enclosed.

This statement is being filed after a Notice of Allowance, but before payment of the issue fee. Each item of information in this statement (i) was cited in the enclosed Office Action from the Korean Patent Office in a counterpart foreign application, the Office Action being dated September 23, 2004, which is not more than three months prior to the filing of this statement, and (ii) to the knowledge of the undersigned, was not first cited in any communication from a foreign patent office in a counterpart application which was more than three months prior to the filing date of this statement. A check for \$180 in payment of the late submission fee of C.F.R. §

12/27/2004 HALI11 00000038 10076154

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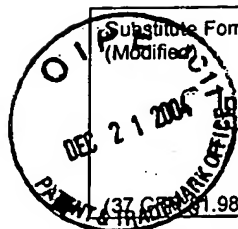
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December 21, 2004

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Substitute Form PTO-1449 (Modified)		Department of Commerce Patent and Trademark Office	Attorney's Docket No. 10417-118001	Application No. 10/076,154
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)			Applicant Yoshinori Hino et al.	
(37 CFR 1.98(b))			Filing Date February 14, 2002	Group Art Unit 2826

**U.S. Patent Documents**

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

**Foreign Patent Documents or Published Foreign Patent Applications**

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation Abstract	
							Yes	No
	AL	09-148526	06/06/1997	Japan			X	
	AM	2000-174268	06/23/2000	Japan			X	
	AN							
	AO							
	AP							


**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Attorney's Docket No. 10417-118001	Express Mail Label No. ET931344527US	Mailing Date December 21, 2004	<b>For PTO Use Only</b> Do Not Mark in This Area  
Application No. 10/076,154	Filing Date February 14, 2002	Attorney/Secretary Init SXB/gzm	
Title of the Invention SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF			
Applicant Yoshinori Hino et al.			
Client Reference No. F51-142893M/SW			
Enclosures · Information Disclosure Statement (2 pages) · Check for \$180.00 · Form PTO-1449 (1 page) · Documents listed on the Form PTO-1449 (2 documents) · Other: Copy of Korean Office Action (9/23/04) 